

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Ricky Amos, et al.                      **Examiner:** Matthew C. Landau  
**Serial No:** 09/995,031                      **Art Unit:** 2815  
**Filed:** November 29, 2001                      **Docket:** YOR920010633US1 (19031)

**For:** HIGH TEMPERATURE PROCESSING COMPATIBLE METAL GATE ELECTRODE  
FOR pFETs AND METHOD FOR FABRICATION

**Confirmation No:** 9669                      **Dated:** July 24, 2007

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.116**

Sir:


In response to the Office Action dated April 25, 2007, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

---

**CERTIFICATE OF ELECTRONIC FILING**

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on **July 24, 2007**.

**Dated: July 24, 2007**

  
\_\_\_\_\_  
Leslie S. Szivos, Ph.D.